

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/815,020	ANANDAN ET AL.	
Examiner	Art Unit	
Mike Qi	2871	

SEARCHED					
Class	Subclass	Date	Examiner		
349	84,61 78,79	9/18/2006	ZQQ		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
East search; US-PGPUB;USPAT;USOCR;FPRS: EPO;JPO;DERWENT;IBM_TDB; update search; (see printout)	9/18/2006	ZQQ
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